Links for Refl1D:

https://github.com/reflectometry/refl1d

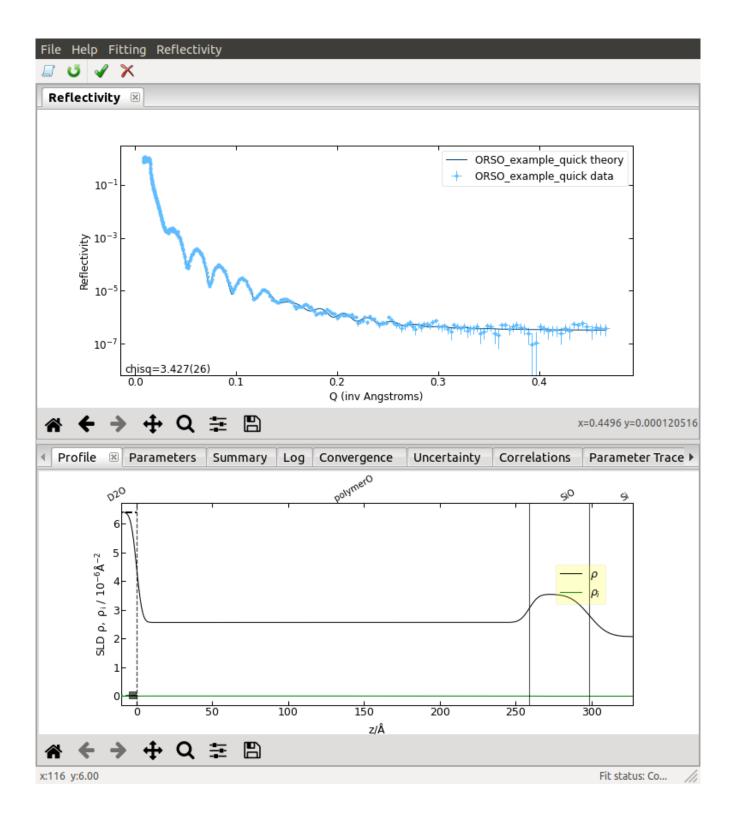
https://github.com/bumps/bumps

https://refl1d.readthedocs.io/en/latest/

https://pages.nist.gov/reflectometry-calculators/reflectivity-calculator.html

```
Here is the model file:
from refl1d.names import *
from refl1d.probe import make probe
from numpy import *
# LOAD DATA AND CREATE A PROBE
probe = load4('ORSO_example_quick.ort',L=10.0,dL=0.1,FWHM=True)
#Polymer
polymer rho = 2.7
polymer t = 259
polymer_sig = 5
# SiO2
SiO t = 30
SiO sig = 5
SiO_{rho} = 3.545
# Si
Si sig = 5.0 \#Interfacial roughness
Si rho = 2.069
# D2O
D20_{rho} = 6.4024
polymer = SLD(name="polymerO",rho=polymer rho)
SiO = SLD(name="SiO",rho=SiO_rho)
Si = SLD(name="Si",rho=Si rho)
D2O = SLD(name = "D2O", rho = D2O_rho)
sample=(D2O(100,3)
|polymer(polymer_t,polymer_sig)
|SiO(SiO_t,SiO_sig)
(Si)
# CONSTRAINTS
# probe.theta_offset.value = th
probe.intensity.value = 1
```

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probe.background.value = 1e-8
# probe.theta offset = probe.pp.theta offset
# FIT PARAMETERS
# offsets
probe.intensity.range(0.5,5)
probe.background.range(1e-11,1e-6)
#probe.theta offset.range(-0.2,0.2)
# probe.sample broadening.range(0,0.1)
polymer.rho.pmp(5)
polymer.irho.range(0,2)
sample[polymer].interface.pmp(5)
sample[polymer].thickness.pmp(5)
sample[SiO].interface.range(1,50)
sample[SiO].thickness.range(1,100)
# EQUALITY CONSTRAINTS:
#sample[Si].interface = sample[SiO].interface
# EXPRESSION CONSTRAINTS
#sample[Si].interface = sample[SiO].interface + 2.0
#GGG
sample[Si].interface.range(1,50)
# sample[GGG].rho.pmp(4)
# sample[GGG].magnetism.rhoM.range(0,4)
# PROBLEM DEFINITION
zed = 2 # microslabbing bin size, in A
alpha = 0.0 # integration factor - leave this at zero
step = False
M = Experiment(sample=sample, probe=probe, dz=zed,dA=alpha,step_interfaces=step)
problem = FitProblem(M)
problem.name = "OopsieltUpsideDown"
And here are the results:
```



| ◆ Profile Parameters | Summary | ⊠ Log | Convergence | Uncertainty | Correlations | Parameter Trace ▶ | |
|-----------------------------|-------------|--------------|-------------|-------------|--------------|---------------------|--|
| Fit Parameter | | Value | Minimum | n Maximu | m | | |
| background | | | | | 3.246000 | 3.2460000000001e-11 | |
| intensity | | | | | 0.8857 | 0.5 | |
| polymerO interface | | | | | 4.833 | 4.75 | |
| polymerO irho | lymerO irho | | | | 0.006137 | 0.00613799999990 | |
| polymerO rho | 0 | | | | 2.561 | 2.56 | |
| polymerO thickness | | | | | 259.0 | 246 | |
| SiO interface | | | | | 9.572000 | 9.5720000000001 | |
| SiO thickness | | |) | | 39.56 | 1 | |
| Si interface | | 0 | | | 13.54000 | 00000001 | |
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